PATENT

Atty Docket No.: 10004808-1

#### In The U.S. Patent and Trademark Office

RECEIVED CENTRAL FAX CENTER

In Re the Application of:

AUG 2 4 2006

Inventor(s): Osamu S. Nakagawa et al.

Confirmation No.: 3635

Serial No.:

09/891,324

Examiner: Schillinger, Laura M.

Filed:

June 27, 2001

Group Art Unit:

2813

Title:

PROCESS FOR HIGH-DIELECTRIC CONSTANT METAL-INSULATOR

METAL CAPACITOR IN VLSI MULTI-LEVEL METALIZATION

**SYSTEMS** 

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

#### CERTIFICATE OF FACSIMILE TO THE USPTO

I hereby certify that this correspondence is being transmitted to the Patent and Trademark Office facsimile number (571) 273-8300 on August 24, 2006. This correspondence contains the following document(s):

1 sheet of Transmittal Letter for Response/Amendment (2 copies).

13sheets of Amendment Under 37 C.F.R. § 1.111.

Respectfully submitted,

MANNAVA & KANG, P.C.

August 24, 2006

Timothy B. Kang

Registration No.: 46,423

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P. 002/016

PATENT APPLICATION

Intellectual Property Administration P. O. Box 272400 Fort Collins, Colorado 80527-2400

ATTORNEY DOCKET NO. \_\_\_10004808-1

#### IN THE

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PROCESS FOR HIGH-DIELECTRIC CONSTANT METAL-INSULATOR METAL CAPACITOR

IN VLSI MULTI-LEVEL METALIZATION SYSTEMS

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Mail Stop Amendment **Commissioner For Patents** PO Box 1450 Alexandria, VA 22313-1450

AUG 2 4 2006

# TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Transmitted herewith is/are the following in the above-identified application: Petition to extend time to respond Rosponso/Amendment () New fee as calculated below Supplemental Declaration ( )  $(\mathbf{X})$ No additional fee ( ) Other: \_ \_ (fee \$

(1) FOR			HIGHEST	4) NUMBER SLY PAID FOR	(5) PRESENT EXTRA		(6) RATE		(7) ADDITIONAL FEES	
TOTAL CLAIMS	20 MINUS		20		= 0		×	\$50	\$	0
Indep. Claims	3	MINUS		3	=	Ó	х	\$200	\$	0
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to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this sheet is enclosed.

Respectfully submitted.

(X) I hereby cartify that this paper is being transmitted to the Patent and Trademark Office (acsimile number 1571) 273-8300 on Aug 24 2006 Number of pages: 19
Typed Name: Timothy B. Keng
Signature:

Qsamu S. Nakagawa

Timothy B. Kang

Attorney/Agent for Applicant(s)

Reg. No. 46,423 P. O. Box 272400

Fort Collins, Colorado 80527-2400

ATTORNEY DOCKET NO. 10004808-1

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Mail Stop Amendment Commissioner For Patents PO Box 1450

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Alexandria, VA 22313-1450

AUG 2 4 2006

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Sir:				

Transmitted herewith is/are the following in the above-identified application:

Other:								_	(fcc \$_	•	
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(1) FOR			NUMBER HIGHEST				(S) PRESENT EXTRA		(6) RATE	(7) ADDITIONA FEES	
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indep. Claims			MINUS		3			× \$200		\$	0
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	•						o	THER	FEES	\$	
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Ch 5 ap CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

Osamu S. Nakagawa

(X) I horoby certify that this paper is being trunsmitted to the Patent and Trademark Office fucalmile number <u>(571) 273-8300</u> on <u>Aug. 24, 2005</u>

Number of pages: 19

Typed Name: Timothy B. Kang

Timothy B. Kang

Signature;\_

Attorney/Agent for Applicant(s) Reg. No. 46,423

AUG-24-2006(THU) 22:55

MANNAVA & KANG, P.C.

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P. 004/016

HEWLETT-PACKARD COMPANY

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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

# AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Official Action dated May 24, 2006, kindly amend the application identified above as follows. In the following, underlines indicate additions and strikethroughs indicate deletions.